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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/623,482	07/18/2003	Michael A. Todd	ASMEX.376A	4562	
68852 7590 10/10/2007 KNOBBE, MARTENS, OLSEN & BEAR LLP 2040 MAIN STREET			EXAMINER		
			POMPEY, RON EVERETT		
FOURTEENTH FLOOR IRVINE, CA 92614		·	ART UNIT	PAPER NUMBER	
			2812		
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			MAIL DATE	DELIVERY MODE	
			10/10/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Supplemental

Application No.		Applicant(s)		
	10/623,482	TODD ET AL.		
	Examiner .	Art Unit		
	Ron E. Pompey	2812		

	10/623,482	I TODD ET AL.		
Notice of Allowability	Examiner .	Art Unit		
	Ron E. Pompey	2812		
The MAILING DATE of this communication appearable claims being allowable, PROSECUTION ON THE MERITS IS therewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIP of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in t or other appropriate commun GHTS. This application is sul	his application. If not include ication will be mailed in due	ed course. THIS	
1. \boxtimes This communication is responsive to <u>9-27-07</u> .				
2. $igtimes$ The allowed claim(s) is/are <u>1-17,19-21,25-36,38-48 and 50</u>).			
 Acknowledgment is made of a claim for foreign priority ur a) ☐ All b) ☐ Some* c) ☐ None of the: 	nder 35 U.S.C. § 119(a)-(d) or	(f) .		
 Certified copies of the priority documents have 	been received.			
Certified copies of the priority documents have	been received in Application	No		
3. Copies of the certified copies of the priority do	cuments have been received i	n this national stage applicat	tion from the	
International Bureau (PCT Rule 17.2(a)).	•			
* Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		reply complying with the rec	luirements	
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 			OTICE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.			
(a) including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO-948) attached		
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date				
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in	the Office action of		
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			back) of	
 DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT 			lote the	
Attachment(s)				
1. Notice of References Cited (PTO-892)		5. Notice of Informal Patent Application		
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Sun Paper No./M	ail Date		
 Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date <u>9-27-07</u> 		mendment/Comment		
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's S	atement of Reasons for Allo	wance	
c. Diological material	9. 🗌 Other	11111.	4.	
	MICH SUPERVISO	AEL LEBENTRITT DRY PATENT EXAMINER	<i>y</i> -	

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SUPPLEMENTAL ALLOWANCE

Allowable Subject Matter

1. Claims 1-17, 19-21, 25-36, 38-48 and 50 are allowed.

2. The following is an examiner's statement of reasons for allowance: the prior art of record, either singly or in combination, fails to disclose the limitations of: multiple chemical deposition cycles deposition, a silicon layer of a thickness of more than one monolayer on a plurality of substrates in a hot wall batch process chamber by exposing the substrates to a **supply of trisilane**; interrupting the supply of trisilane; forming a silicon compound layer by exposing the silicon layer to a reactive species after interrupting the supply, wherein the silicon compound layer has a thickness non-uniformity of about 5% or less and a step coverage of about 80% or greater, and further comprising repeating depositing, interrupted and forming in a plurality of cycles.

There is prior art that shows depositing a dielectric layer using tri-silane as the source gas. However, due to applicant's declaration, that one of ordinary skill would not think to use tri-silane source gas in a cyclical deposition (ald, ale or cld) process to form thin uniform layer because of the high reactivity of tri-silane, and a lack of prior art showing the bold and underlined limitation the examiner allowed the case.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ron E. Pompey whose telephone number is (571) 272-1680. The examiner can normally be reached on 9AM - 5PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael S. Lebentritt can be reached on (571) 272-1873. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Ron Pompey

70. 2012 10/05/07 SUPERVISORY PATENT EXAMINER